

**Change Of Attorney Or Agent's Address In Application
(37 CFR 1.8(a))**

Docket No.
3521.182

In Re Application Of: **SOMIT TALWAR, ET AL.**

Serial No.
10/762,861

Filing Date
January 22, 2004

Examiner

Group Art Unit

Invention: **LASER THERMAL ANNEALING OF LIGHTLY DOPED SILICON SUBSTRATES**

TO THE COMMISSIONER FOR PATENTS

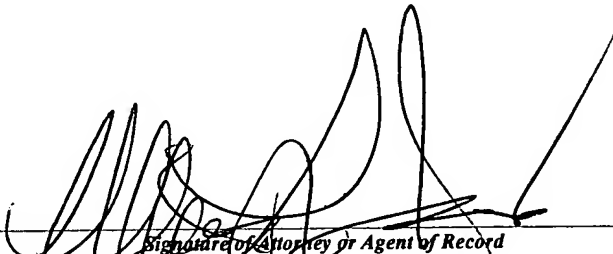
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Dated: **March 26, 2004**


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